

MG63P/64P/65P 0.25µm Embedded DRAM/ Customer Structured Arrays

November 1998



Oki Semiconductor

MG63P/64P/65P

0.25µm Embedded DRAM/Customer Structured Arrays

DESCRIPTION

Oki's 0.25 μ m MG63P/64P/65P Application-Specific Integrated Circuit (ASIC) provides the ability to embed large blocks of Synchronous DRAM (SDRAM) into an embedded array architecture called the Customer Structured Array (CSA). Utilizing Oki's leadership in DRAM technologies and wide experience of embedding SDRAM in logic products, Oki is able to integrate SDRAM and ASIC technology. The merged DRAM/ASIC process efficiently implements the Oki stacked capacitor memory cell. The MG63P/64P/65P CSA series uses three, four, and five metal process layers, respectively, on 0.25 μ m drawn (0.18 μ m L-effective) CMOS technology. The semiconductor process is adapted from Oki's production-proven 64- Mbit DRAM manufacturing process.

The 0.25 μ m family provides significant performance, density, and power improvement over previous 0.30 μ m and 0.35 μ m technologies. An innovative 4-transistor cell structure provides 30 to 50% less power and 30 to 50% more usable gates than traditional cell designs. The Oki 0.25 μ m family operates using 2.5-V VDD core with optimized 3-V I/O buffers. The 3-, 4-, and 5-layer metal MG63P/64P/65P CSA series contains 21 devices each, offering up to 868 I/O pads and over 5.4M raw gates. These CSA array sizes are designed to fit the most popular quad flat pack (QFP), low profile QFPs (LQFPs), thin QFPs (TQFPs), and plastic ball grid array (PBGA) packages. Oki uses the Artisan Components memory compiler which provides high performance, embedded synchronous single- and dual-port SRAM macrocells for CSA designs. As such, the MG63P/64P/65P series is suited to memory-intensive ASICs and high volume designs where fine tuning of package size produces significant cost or real-estate savings.

The embedded SDRAM represents part of Oki's menu of major IP core functions for the $0.25~\mu m$ ASIC products. Other functions include ARM7TDMI, Gb Ethernet MAC, PLL, PCI and others in planning.

FEATURES

- 0.25µm drawn 3-, 4-, and 5-layer metal CMOS
- Optimized 2.5-V core
- Optimized 3-V I/O
- CSA architecture availability
- 100 MHz embedded SDRAM cores up to 16 Mb per occurrence
- 77-ps typical logic gate propagation delay (for a 4x-drive inverter gate with a fanout of 2 and 0 mm of wire, operating at 2.5 V)
- Over 5.4M raw gates and 868 I/O pads using 60μ staggered I/O
- \bullet User-configurable I/O with VSS, VDD, TTL, 3-state, and 1- to 24-mA options
- Slew-rate-controlled outputs for low-radiated noise
- H-clock tree cells which reduces the maximum skew for clock signals

- Low 0.2μW/MHz/gate power dissipation
- User-configurable single- and dual-port memories (SRAM)
- Specialized IP cores and macrocells including 32-bit ARM7TDMI CPU, phase-locked loop (PLL), and peripheral component interconnect (PCI) cells
- Floorplanning for front-end simulation, backend layout controls, and link to synthesis
- Joint Test Action Group (JTAG) boundary scan and scan path Automatic Test Pattern Generation (ATPG)
- Support for popular CAE systems including Cadence, IKOS, Mentor Graphics, Model Technology, Inc. (MTI), Synopsys, and Viewlogic

MG63P/64P/65P FAMILY LISTING

Series (MG6x)	No. of Pads	No. of Rows	No. of Columns	No. of Raw Gates	MG63P 3LM Usable Gates	MG64P 4LM Usable Gates	MG65P 5LM Usable Gates
B02	68	84	280	23,520	20,933	22,344	22,344
B04	108	144	480	69,120	57,370	65,664	65,664
B06	148	204	680	138,720	106,814	131,784	131,784
B08	188	264	880	232,320	167,270	218,381	220,704
B10	228	324	1,080	349,920	234,446	311,429	332,424
B12	268	384	1,280	491,520	309,658	412,877	466,944
B14	308	444	1,480	657,120	387,701	519,125	611,122
B16	348	504	1,680	846,720	474,163	635,040	745,114
B18	388	564	1,880	1,060,320	572,573	763,430	901,272
B20	428	624	2,080	1,297,920	648,960	882,586	1,025,357
B22	468	684	2,280	1,559,920	732,974	982,498	1,154,045
B24	508	744	2,480	1,845,120	848,755	1,107,072	1,310,035
B26	548	804	2,680	2,154,720	969,624	1,249,738	1,465,210
B28	588	864	2,880	2,488,320	1,094,861	1,393,459	1,642,291
B30	628	924	3,080	2,845,920	1,223,746	1,536,797	1,821,389
B32	668	984	3,280	3,227,520	1,355,558	1,678,310	2,001,062
B34	708	1,044	3,480	3,633,120	1,489,579	1,816,560	2,179,872
B36	748	1,104	3,680	4,062,720	1,625,088	1,950,106	2,356,378
B38	788	1,164	3,880	4,516,320	1,761,365	2,077,507	2,529,139
B40	828	1,224	4,080	4,993,920	1,897,690	2,197,325	2,696,717
B42	868	1,284	4,280	5,495,520	2,033,342	2,308,118	2,857,670

5 layer metal: MG65PBxx 4 layer metal: MG64PBxx 3 layer metal: MG63PBxx

ARRAY ARCHITECTURE

The primary components of a 0.25µm MG63P/64P/65P circuit include:

- I/O base cells
- 60µm pad pitch
- Configurable I/O pads for V_{DD}, V_{SS}, or I/O (optimized 3-V I/O)
- V_{DD} and V_{SS} pads dedicated to wafer probing
- Separate power bus for output buffers
- Separate power bus for internal core logic and input buffers
- Core base cells containing N-channel and P-channel pairs, arranged in column of gates
- Isolated gate structure for reduced input capacitance and increased routing flexibility

Each array has 24 dedicated corner pads for power and ground use during wafer probing, with four pads per corner. The arrays also have separate power rings for the internal core functions (V_{DDC} and V_{SSC}) and output drive transistors (V_{DDO} and V_{SSO}).

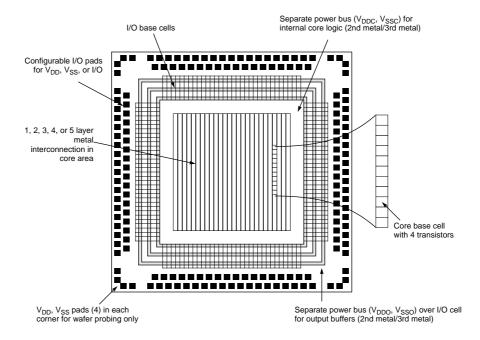


Figure 7. MG65P Array Architecture

MG63P/64P/65P CSA Layout Methodology

The procedure to design, place, and route a CSA follows.

- 1. Select suitable base array frame from the available predefined sizes. To select an array size:
 - Identify megacell functions (e.g. embedded SDRAM) required and minimum array size to hold macrocell functions.
 - Add together all the area occupied by the required random logic and macrocells and select the optimum array.
- 2. Make a floor plan for the design's megacells.
 - Oki Design Center engineers verify the master slice and review simulation.
 - Oki Design Center or customer engineers floorplan the array using Oki's supported Cadence DP3 or Gambit GFP and customer performance specifications.
 - Using Oki CAD software, Design Center engineers remove the SOG transistors and replace them with diffused memory macrocells to the customer's specifications.

Figure 8 shows an array base after placement of the optimized memory macrocells.

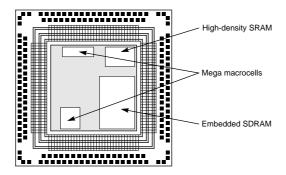


Figure 8. Optimized Memory Macrocell Floor Plan

- 3. Place and route logic into the array transistors.
 - Oki Design Center engineers use layout software and customer performance specifications to connect the random logic and optimized memory macrocells.

Figure 9 marks the area in which placement and routing is performed with cross hatching.

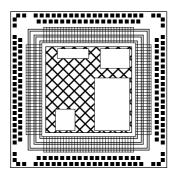


Figure 9. Random Logic Place and Route

Figure 10 illustrates Oki's Embedded DRAM ASIC. Oki provides two types of reconfigurable SDRAM cores generated from the compiler.

Reconfigurable SDRAM Core

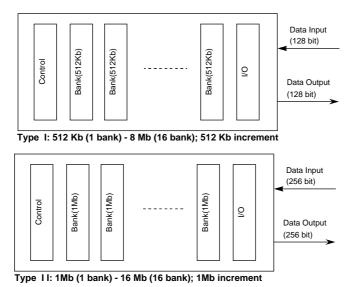


Figure 10. SDRAM Compiler

SDRAM Core Functional Specification

Density	Type I: 512kb (1BK) - 8Mb (16BK) by 512 kb Type II: 1 Mb (1BK) - 16 Mb (16 BK) by 1 Mb
Bit Organization	x16/x32/x64/x128/x256 (x256 Type II Only)
Maximum Clock Rate	100 MHz
VDD	2.5V
CAS Latency	2
Burst Length	1
Write Latency	0
DQM Latency	0: Write, 2: Read
Refresh	512 Refresh cycles/8 ms
Macro Pinout	CLK, ACT, PRE, RD, WR, AX(8:0), AY(2:0), BAX(2:0), BAY(2:0), DQM (15:0), D(127:0), Q9127:0), REF, RST, test pins

AC SPECIFICATIONS

SDRAM Core Timings

Parameter	Description	Value and Unit
tCK	Clock cycle time	10 ns
tAC	Clock access time	6 ns
tCH	Clock high pulse width	3 ns
tCL	Clock low pulse width	3 ns
tOH	Data output hold time	2 ns
tSI	Input setup time	3 ns
tHI	Input hold time	3 ns
tRCD	RAS to CAS delay time	30 ns
tWR	Write recovery time	10 ns
tRC	Bank cycle time	90 ns
tRAS	Active command period	60 ns
tRP	Precharge time	30 ns
tRRD	Bank to bank delay time	10 ns
tCCD	CAS to CAS delay time	1 CLK

ELECTRICAL CHARACTERISTICS

Absolute Maximum Ratings ($V_{SS} = 0 \text{ V}, T_J = 25^{\circ}\text{C}$) [1]

Parameter	Symbol	Rated Value	Unit
Power supply voltage	V _{DD} Core (2.5 V)	-0.3 to +3.6	
	V _{DD} I/O (3.3 V)	-0.3 to +4.6] ,
Input voltage (Input Buffer)	V _I	-0.3 to +4.6]
Output voltage (Output Buffer)	V ₀	-0.3 to +4.6	
Input current (Input Buffer)	I _I	-10 to +10	m A
Output current per I/O (Output Buffer)	I ₀	-24 to +24	- mA
Storage temperature	T _{STG}	-65 to +150	°C

^{1.} Permanent device damage may occur if ABSOLUTE MAXIMUM RATINGS are exceeded. Functional operation should be restricted to the conditions in the other specifications of this data sheet. Exposure to absolute maximum rating conditions for extended periods may affect device reliability.

Recommended Operating Conditions (V_{SS} = 0 V)

Parameter	Symbol	Rated Value	Unit
Power supply voltage	V _{DD} Core (2.5 V)	+2.25 to +2.75	V
	V _{DD} I/O (3.3 V)	+3.0 to +3.6]
Junction temperature	T _j	-40 to +85	°C

DC Characteristics (V_{DD} Core = 2.25 to 2.75 V, V_{DD} I/O = 3.0 to 3.6 V, V_{SS} = 0 V, T_j = -40° to +85°C)

Parameter	Symbol	Conditions	Min.	Typ. ^[1]	Max.	Unit
High-level input voltage	V _{IH}	TTL input (normal)	2.0	-	V _{DD}	
Low-level input voltage	V _{IL}	TTL input (normal)	-0.0	-	0.8	1
TTL- level Schmitt	V _{t+}	TTL input	-	1.5	2.0	1
Trigger input buffer Threshold voltage	V _{t-}		0.7	1.0	-	V
Till Callold Voltage	ΔV_t	V _{t+} - Vt-	0.4	0.5	-	1
High-level output voltage (Output buffer)	V _{OH}	I _{OH} = -100 μA	V _{DD} -0.2	-	-	1
		I _{OH} = -1, -2, -4, -6, -8, -12, -24 mA	2.4	-	-	
Low-level output voltage (Output buffer)	V _{OL}	I _{OL} = 100 μA	-	-	0.2	μА
		I _{OL} = 1, 2, 4, 6, 8, 12, 24 mA	-	-	0.4	
High-level input current (Input buffer)	I _{IH}	$V_{IH} = V_{DD}$	-	-	10	
		$V_{IH} = V_{DD}$ (50-k Ω pull-down)	10	66	200	
Low-level input current (Normal input buffer)	I _{IL}	V _{IL} = V _{SS}	-10	-	10	
		$V_{IL} = V_{SS}$ (50-k Ω pull-up)	-200	-66	-10	
		$V_{IL} = V_{SS} (3-k\Omega \text{ pull-up})$	-3.3	-1.1	-0.3	mA
3-state output leakage current	I _{OZH}	$V_{OH} = V_{DD}$	-10	-	10	
(Normal input buffer)		$V_{OH} = V_{DD} (50-k\Omega \text{ pull-down})$	10	66	200	μA
	I _{OZL}	V _{OL} = V _{SS}	-10	_	10	μА
		$V_{OL} = V_{SS} (50-k\Omega \text{ pull-up})$	-200	-66	-10	^{μΑ}
		$V_{OL} = V_{SS} (3-k\Omega \text{ pull-up})$	-3.3	-1.1	-0.3	mA
Stand-by current [2]	I _{DDQ}	Output open, $V_{IH} = V_{DD}$, $V_{IL} = V_{SS}$	De	sign Depende	ent	μA

^{1.} Typical condition is V_{DD} I/O = 3.3 V, V_{DD} Core = 2.5 V, and T_j = 25°C on a typical process.

^{2.} RAM/ROM should be in powerdown mode.

AC Characteristics (Core V_{DD} = 2.5 V, V_{SS} = 0 V, T_j = 25°C)

	Parameter	Driving Type	Conditions [1] [2]	Rated Value ^[3]	Unit
Internal gate	Inverter	1X		0.091	
propagation delay		2X		0.079	
		4X		0.065	
	2-input NAND	1X	F/O = 2, L = 0 mm	0.13	
		2X	V _{DD} = 2.5 V	0.11	
		4X	1	0.09	ns
	2-input NOR	1X		0.16	
		4X		0.13	
	Inverter	1X		0.24	
		2X	1	0.18	
		4X		0.12	
	2-input NAND	1X	F/O = 2, L = standard	0.30	
		2X	wire length V _{DD} = 2.5 V	0.20	
		4X		0.14	
	2-input NOR	1X	1	0.41	
		4X	1	0.24	
Toggle frequency			F/O = 1, L = 0 mm	1100	MHz

- 1. Input transition time in 0.15 ns / 2.5 $\rm V.$
- 2. Typical condition in V_{DD} = 2.5 V and T_j = 25°C for a typical process.
- 3. Rated value is calculated as an average of the L-H and H-L delay times of each macro type on a typical process.

AC Characteristics (I/O V_{DD} = 3.3 V, V_{SS} = 0 V, T_j = 25°C)

Parameter		Conditions	Rated Value	Unit	
Input buffer propagation	delay		F/O = 2, L = standard wire length	0.29	ns
Output buffer	Push-pull	4 mA	CL = 20 pF	1.73	ns
propagation delay	Normal Output	8 mA	CL = 50 pF	1.96	ns
	Buffer	12mA	CL = 100 pF	2.52	ns
Output buffer	Push-pull	12 mA	CL = 100 pF	3.79 (r)	ns
transition time ^[1]	Normal output	1		3.07 (f)	ns
	Buffer				ns

1. Output rising and falling times are both specified over a 10 to 90% range.

MACRO LIBRARY

Oki Semiconductor supports a wide range of macrocells and macrofunctions, ranging from simple hard macrocells for basic Boolean operations to large, user-parameterizable macrofunctions. The following figure illustrates the main classes of macrocells and macrofunctions available.

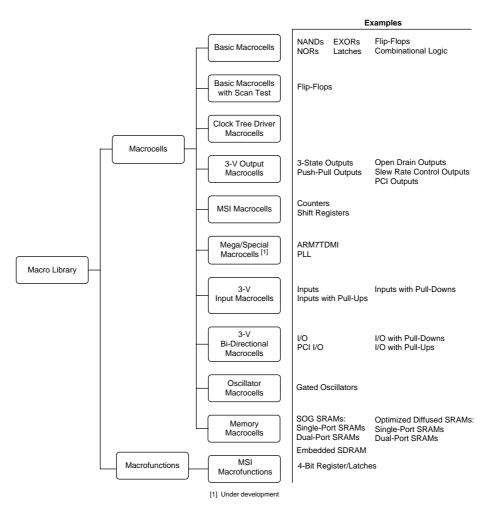


Figure 11. Oki Macrocell and Macrofunction Library

Macrocells for Driving Clock Trees

Oki offers clock-tree drivers that minimize clock skew. The advanced layout software uses dynamic driver placement and sub-trunk allocation to optimize the clock-tree implementation for a particular circuit. Features of the clock-tree driver-macrocells include:

- True RC back annotation of the clock network
- Automatic fan-out balancing
- Dynamic sub-trunk allocation
- Single clock tree driver logic symbol
- Automatic branch length minimization
- Dynamic driver placement
- Up to four clock trunks

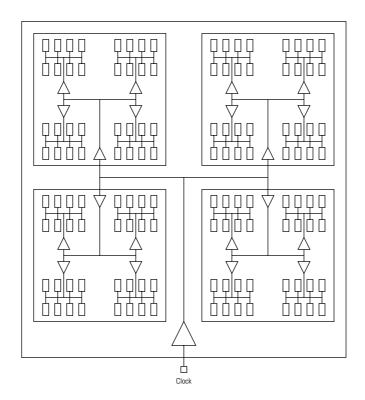


Figure 12. Clock Tree Structure

OKI ADVANCED DESIGN CENTER CAD TOOLS

Oki's advanced design center CAD tools include support for the following:

- Floorplanning for front-end simulation and back-end layout control
- Clock tree structures improve first-time silicon success by eliminating clock skew problems
- JTAG Boundary scan support
- Power calculation which predicts circuit power under simulation conditions to accurately model package requirements

Vendor	Platform	Operating System ^[1]	Vendor Software/Revision ^[1]	Description
Cadence	HP9000, 7xx IBM RS6000 Sun [®] [2]	HP-UX AIX SunOS, Solaris	Composer™ Verilog™ NC-Verilog™ Veritime™ Verifault™ Concept™ ^[3] Leapfrog™	Design capture Simulation Simulation Timing analysis Fault grading Design capture VHDL simulation
IKOS	HP9000, 7xx, Sun ^[2]	HP-UX, SunOS, Solaris	NSIM Gemini/Voyager	Simulation
Mentor Graphics™	HP9000, 7xx Sun ^[2]	HP-UX SunOS, Solaris	IDEA™ QuickVHDL QuickSim II™ DFT Advisor Fastscan	Design capture VHDL simulation Logic simulation Test synthesis ATPG
Model Technology Inc. (MTI)	HP9000, 7xx Sun ^[2] PC	HP-UX SunOS, Solaris Win/NT™	V-System	VHDL simulation
Synopsys (Interface to Mentor Graphics, VIEWLogic)	IBM RS6000 HP9000, 7xx Sun ^[2]	AIX HP-UX SunOS, Solaris	Design Compiler™ HDL/VHDL Compiler™ Test Compiler™ VSS™	Compilation Design synthesis Test synthesis VHDL simulation
VIEWLogic	PC Sun ^[2]	Windows™, Win/NT™ ^[4] SunOS, Solaris	Powerview™ Fusion HDL	Simulation VHDL/Verilog™ Simulation

^{1.} Contact Oki Application Engineering for current software versions.

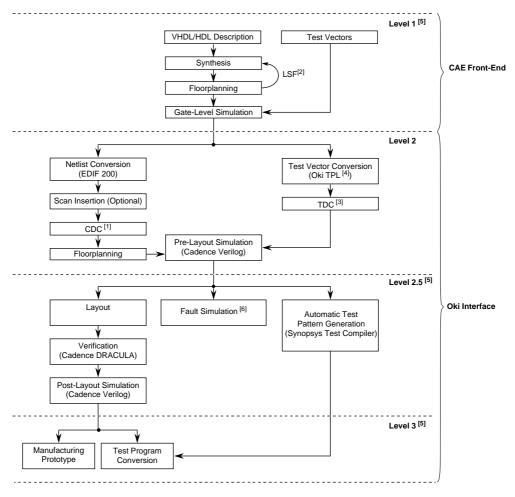
^{2.} Sun or Sun-compatible.

^{3.} Sun and HP platform only.

^{4.} In development.

Design Process

The following figure illustrates the overall IC design process, also indicating the three main interface points between external design houses and Oki ASIC Application Engineering.



- Oki's Circuit Data Check program (CDC) verifies logic design rules
- Oki's Link to Synthesis Floorplanning toolset (LSF) transfers post-floorplanning timing for resynthesis
 Oki's Test Data Check program (TDC) verifies test vector rules
 Oki's Test Pattern Language (TPL)

- Standard Customer-Oki design interfaces available in addition to standard level 2
 Standard design process includes fault simulation

Figure 13. Oki's Design Process

Automatic Test Pattern Generation

Oki's 0.25µm ASIC technologies support ATPG using full scan-path design techniques, including the following:

- Increases fault coverage ≥ 95%
- Uses Synopsys Test Compiler
- · Automatically inserts scan structures
- Connects scan chains
- Traces and reports scan chains
- · Checks for rule violations
- Generates complete fault reports
- · Allows multiple scan chains
- · Supports vector compaction

ATPG methodology is described in detail in Oki's 0.25µm Scan Path Application Note.

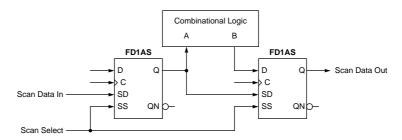


Figure 14. Full Scan Path Configuration

Floorplanning Design Flow

Oki offers two floorplanning tools for high-density ASIC design: Cadence DP3, and Gambit GFP. The two main purposes for Oki's floorplanning tools are to:

- Ensure conformance of critical circuit performance specifications
- Shorten overall design TAT

In a traditional design approach with synthesis tools, timing violations after prelayout simulation are fixed by manual editing of the netlist. This process is difficult and time consuming. Also, there is no physical cluster information provided in the synthesis tool, and so it is difficult to synthesize logic using predicted interconnection delay due to wire length. Synthesis tools may therefore create over-optimized results.

To minimize these problems, Synopsys proposed a methodology called, "Links to Layout (LTL)". Based on this methodology, Oki developed an interface between Oki's Floorplanner and the Synopsys environment, called Link Synopsys to Floorplanner (LSF). As not every Synopsys user has access to the Synopsys Floorplan Management tool, Oki had developed the LSF system to support both users who can access Synopsys Floorplan Management and users who do not have access to Synopsys Floorplan Management.

More information on OKI's floorplanning capabilities is available in Oki's Application Note, *Using Oki's Floorplanner: Standalone Operation and Links to Synopsys*.

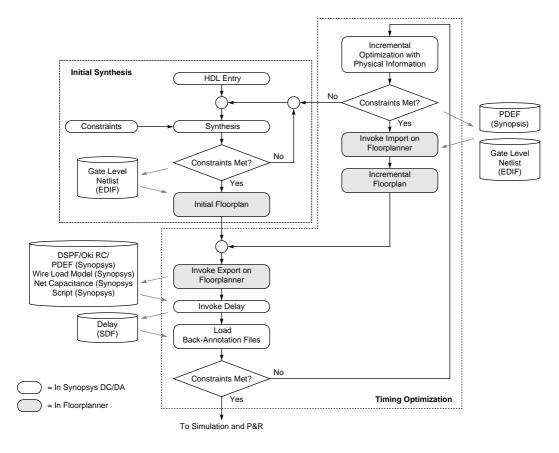


Figure 15. LSF System Design Flow

IEEE JTAG Boundary Scan Support

Boundary scan offers efficient board-level and chip-level testing capabilities. Benefits resulting from incorporating boundary-scan logic into a design include:

- Improved chip-level and board-level testing and failure diagnostic capabilities
- Support for testing of components with limited probe access
- · Easy-to-maintain testability and system self-test capability with on-board software
- · Capability to fully isolate and test components on the scan path
- Built-in test logic that can be activated and monitored
- An optional Boundary Scan Identification (ID) Register

Oki's boundary scan methodology meets the JTAG Boundary Scan standard, IEEE 1149.1-1990. Oki supports boundary scan on both Sea of Gates (SOG) and Customer Structured Array (CSA) ASIC technologies. Either the customer or Oki can perform boundary-scan insertion. More information is available in Oki's JTAG Boundary Scan Application Note. (Contact the Oki Application Engineering Department for interface options.)

PACKAGE OPTIONS

TQFP, LQFP and QFP Package Menu (Preliminary)

				LQFP		Q	QFP	
Base Array	Product Name	I/O Pads [1]	144	176	208	208	240	100
	MG6xPB02	68						•
	MG6xPB04	108						•
	MG6xPB06	148						•
	MG6xPB08	188						•
	MG6xPB10	228			•	•		•
	MG6xPB12	268	•		•	•		•
	MG6xPB14	308	•	•	•	•		•
-	MG6xPB16	348	•	•	•	•		•
-	MG6xPB18	388	•	•	•	•		•
	MG6xPB20	428	•	•	•	•		•
	MG6xPB22	468	•	•	•	•		•
	MG6xPB24	508	•	•	•	•		•
	MG6xPB26	548	•	•	•	•		•
\	MG6xPB28	588	•	•	•	•	•	
	MG6xPB30	628	•	•	•	•	•	
	MG6xPB32	668	•	•	•	•	•	
	MG6xPB34	708	•	•	•	•	•	
	MG6xPB36	748	•	•	•	•	•	
	MG6xPB38	788	•	•	•	•		
	MG6xPB40	828	•	•	•	•		
	MG6xPB42	868	•	•	•	•		
dy Size (mm)		•	20 x 20	24 x 24	28 x 28	28 x 28	32 x 32	14 x ⁻
ad Pitch (mm)			0.5	0.5	0.5	0.5	0.5	0.5

^{1.} I/O Pads can be used for input, output, bi-directional, power, or ground.

^{● =} Available now

BGA Package Menu

				BGA				
Base Array	Product Name	I/O Pads ^[1]	256	352	420	560		
	MG6xPB02	68						
	MG6xPB04	108						
	MG6xPB06	148						
	MG6xPB08	188						
	MG6xPB10	228						
	MG6xPB12	268						
	MG6xPB14	308	•					
	MG6xPB16	348	•					
	MG6xPB18	388	•		•			
	MG6xPB20	428	•		•			
	MG6xPB22	468	•	•	•			
	MG6xPB24	508	•	•	•			
	MG6xPB26	548	•	•	•			
	MG6xPB28	588	•	•	•			
	MG6xPB30	628	•	•	•			
	MG6xPB32	668		•	•			
	MG6xPB34	708		•	•	•		
	MG6xPB36	748		•		•		
	MG6xPB38	788		•		•		
	MG6xPB40	828		•		•		
	MG6xPB42	868				•		
lody Size (mm)	•	•	27x27	35x35	35x35	35x35		
ead Pitch (mm)			1.27	1.27	1.27	1.00		
all Count			256	352	420	560		
Signal I/O			231	304	352	400		
ower Ball			12	16	32	80		
ND Ball			13	32	36	80		

^{1.} I/O Pads can be used for input, output, bi-directional, power, or ground.

⁼ Available now

Notes:

The information contained herein can change without notice owing to product and/or technical improvements.

Please make sure before using the product that the information you are referring to is up-to-date.

The outline of action and examples of application circuits described herein have been chosen as an explanation of the standard action and performance of the product. When you actually plan to use the product, please ensure that the outside conditions are reflected in the actual circuit and assembly designs.

Oki assumes no responsibility or liability whatsoever for any failure or unusual or unexpected operation resulting from misuse, neglect, improper installation, repair, alteration or accident, improper handling, or unusual physical or electrical stress including, but not limited to, exposure to parameters outside the specified maximum ratings or operation outside the specified operating range.

Neither indemnity against nor license of a third party's industrial and intellectual property right, etc. is granted by us in connection with the use of product and/or the information and drawings contained herein. No responsibility is assumed by us for any infringement of a third party's right which may result from the use thereof.

When designing your product, please use our product below the specified maximum ratings and within the specified operating ranges, including but not limited to operating voltage, power dissipation, and operating temperature.

The products listed in this document are intended for use in general electronics equipment for commercial applications (e.g.,office automation, communication equipment, measurement equipment, consumer electronics, etc.). These products are not authorized for use in any system or application that requires special or enhanced quality and reliability characteristics nor in any system or application where the failure of such system or application may result in the loss or damage of property or death or injury to humans. Such applications include, but are not limited to: traffic control, automotive, safety, aerospace, nuclear power control, and medical, including life support and maintenance.

Certain parts in this document may need governmental approval before they can be exported to certain countries. The purchaser assumes the responsibility of determining the legality of export of these parts and will take appropriate and necessary steps, at their own expense, for export to another country.

Copyright 1998 Oki Semiconductor

Oki Semiconductor reserves the right to make changes in specifications at anytime and without notice. This information furnished by Oki Semiconductor in this publication is believed to be accurate and reliable. However, no responsibility is assumed by Oki Semiconductor for its use; nor for any infringements of patents or other rights of third parties resulting from its use. No license is granted under any patents or patent rights of Oki.



Northwest Area

785 N. Mary Avenue Sunnyvale, CA 94086 Tel: 408/720-8940 Fax: 408/720-8965

Southwest Area

2302 Martin Street Suite 250 Irvine, CA 92715 Tel: 714/752-1843

Fax: 714/752-2423

Northeast Area

138 River Road Shattuck Office Center Andover, MA 01810 Tel: 978/688-8687 Fax: 978/688-8896

Southeast Area

1590 Adamson Parkway Suite 220 Morrow, GA 30260 Tel: 770/960-9660

Fax: 770/960-9682

Oki Web Site:

http://www.okisemi.com

Oki FAX Service:

Call toll free 1-800-OKI-6994

Oki Stock No: 320081-001



Corporate Headquarters

785 N. Mary Avenue Sunnyvale, CA 94086-2909 Tel: 408/720-1900

Fax: 408/720-1918